

862.C2205



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
YOSHIYUKI NAGAI, et al.) Examiner: Not Assigned
Application No.: 09/839,139) Group Art Unit: 2881
Filed: April 23, 2001)
For: LASER OSCILLATION APPARATUS,) September 27, 2001
EXPOSURE APPARATUS, SEMI-)
CONDUCTOR MANUFACTURING)
METHOD, SEMICONDUCTOR)
MANUFACTURING FACTORY, AND)
EXPOSURE APPARATUS)
MAINTENANCE METHOD)

The Commissioner for Patents
Washington, D.C. 20231

RECEIVED
OCT 15 2001
TC 2881 MAIL ROOM

REQUEST FOR CORRECTED FILING RECEIPT

Sir:

Applicants' attorneys have received an official Filing Receipt in the above-identified application in which the following is incorrect:

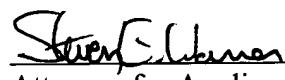
The first-named inventor of the application incorrectly reads "Yashiyuki Nagai" and should read --Yoshiyuki Nagai--.

Applicants request issuance of a corrected Filing Receipt, corrected as shown above.

The Commissioner is authorized to charge Deposit Account No. 06-1205 should any fees be deemed necessary for this correction. A duplicate of this paper is enclosed for this purpose.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants
Steven E. Warner
Registration No. 33,326

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200
SEW\kjs

FILE COPY



UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS
 UNITED STATES PATENT AND TRADEMARK OFFICE
 WASHINGTON, D.C. 20231
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 1616

SERIAL NUMBER 09/839,139	FILING DATE 04/23/2001 RULE	CLASS 372	GROUP ART UNIT 2881	ATTORNEY DOCKET NO. 862.C2205
-----------------------------	-----------------------------------	--------------	------------------------	-------------------------------------

APPLICANTS

Yoshiyuki Nagai, Tochigi, JAPAN;
 Naoto Sano, Tochigi, JAPAN;

** CONTINUING DATA ***** *None* M.C.L.

** FOREIGN APPLICATIONS ***** *Yes* M.C.L.
 JAPAN 2000-126502 04/26/2000

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 06/13/2001

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 11	TOTAL CLAIMS 24	INDEPENDENT CLAIMS 6
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	<i>Naoto Sano</i> Examiner's Signature	Initials			

ADDRESS

05514

TITLE

Laser oscillation apparatus, exposure apparatus, semiconductor device manufacturing method, semiconductor manufacturing factory, and exposure apparatus maintenance method

FILING FEE RECEIVED 1022	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
-----------------------------	---	---